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**\*BIBDATASHEET\***

CONFIRMATION NO. 1880

Bib Data Sheet

<b>SERIAL NUMBER</b> 10/675,862	<b>FILING OR 371(c) DATE</b> 09/30/2003 <b>RULE</b>	<b>CLASS</b> 257	<b>GROUP ART UNIT</b> 2823	<b>ATTORNEY DOCKET NO.</b> TSM03-0150
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**APPLICANTS**

Chao-Yuan Su, Koahsiung City, TAIWAN;  
Pei-Haw Tsao, Tai-Chung, TAIWAN;  
Hsin-Hui Lee, Koahsiung City, TAIWAN;  
Chender Huang, Hsin-Chu, TAIWAN;  
Shang Y. Hou, Hsinchu, TAIWAN;  
Shin Puu Jeng, Hsinchu, TAIWAN;  
Hao-Yi Tsai, Hsinchu, TAIWAN;  
Chenming Hu, Hsin-Chu, TAIWAN;

**\*\* CONTINUING DATA \*\*\*\*\***

This appln claims benefit of 60/462,969 04/15/2003

**\*\* FOREIGN APPLICATIONS \*\*\*\*\*****IF REQUIRED, FOREIGN FILING LICENSE GRANTED****\*\* 12/22/2003**

Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no	<b>STATE OR COUNTRY</b> TAIWAN	<b>SHEETS DRAWING</b> 13	<b>TOTAL CLAIMS</b> 64	<b>INDEPENDENT CLAIMS</b> 3
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials		

**ADDRESS**

43859

**TITLE**

APPARATUS AND METHOD FOR MANUFACTURING A SEMICONDUCTOR WAFER WITH REDUCED DELAMINATION AND PEELING

<b>FILING FEE RECEIVED</b> 1692	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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